

**TRANSMITTAL**

Electronic Version v1.1

Stylesheet Version v1.1.0

**Title of  
Invention****[STRUCTURE APPLIED TO A PHOTOLITHOGRAPHIC PROCESS AND  
METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE]**

Application Number :

Date :

First Named Applicant: Mr. SHUN-LI LIN

Confirmation Number:

Attorney Docket Number: 12398-US-PA

I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.

I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.

Submitted By:

Elec. Sign.

Sign. Capacity

Dr. BELINDA LEE

/Belinda Lee/

Agent

Registered Number: 46,863

Documents being submitted:	Files
us-fee-sheet	12398-usfees.xml us-fee-sheet.xml us-fee-sheet.dtd
us-assignment	12398-usassn.xml us-assignment.xml us-assignment.dtd 12398assignment1.tif 12398assignment2.tif
us-request	12398-usrequ.xml us-request.dtd us-request.xml
application-body	12398-trans.xml us-application-body.xml application-body.dtd wipo.ent mathml2.dtd mathml2-qname-1.mod isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isogr3.ent isomfrk.ent isomopf.ent isomscr.ent isotech.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isolat1.ent isolat2.ent isonum.ent isopub.ent mmlextra.ent mmlalias.ent soextblx.dtd 12398us0001.tif 12398us0002.tif 12398us0003.tif 12398declaration1.tif 12398declaration2.tif
us-declaration	
us-declaration	
<b>Comments</b>	
<p>Please be kindly advised that the indicated fees of this EFS application is intended to be paid by credit card. However, in the event that the payment through credit card is unsuccessful, the Commissioner is authorized to charge the required fees in connection with this application to: Deposit Account No. 50-2620 (Order No. 12398-US-PA ), Deposit Account Name: Jianq Chyun Intellectual Property Office, Authorized User Name: Belinda Lee, E-mail: belinda@jicpgroup.com.tw; usa@jicpgroup.com.tw</p>	